



INDIAN INSTITUTE OF TECHNOLOGY KHARAGPUR

CLASS TEST / LABORATORY TEST

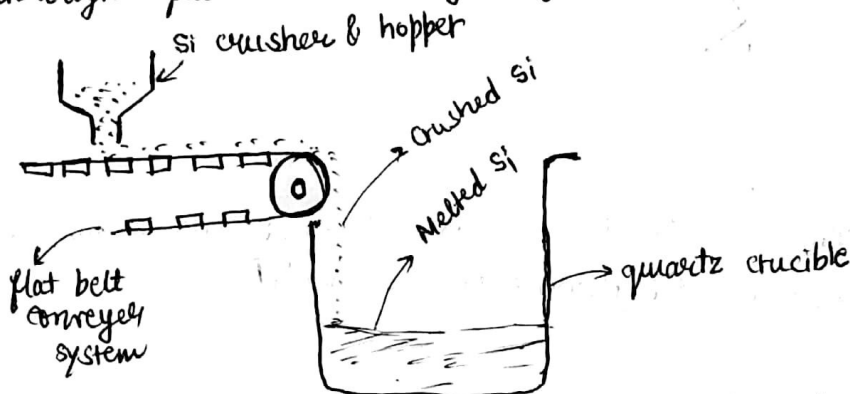
120  
Signature of the Invigilator

EXAMINATION ( Mid-Semester / End-Semester)						SEMESTER (Autumn / Spring)					
Roll Number	1	4	M	E	0	0	0	0	Section	Name	FELIX KJELLBERG
Subject Number	M	E	6	0	0	0	6	-	Subject Name	ELECTRONIC PKG. & MFG.	

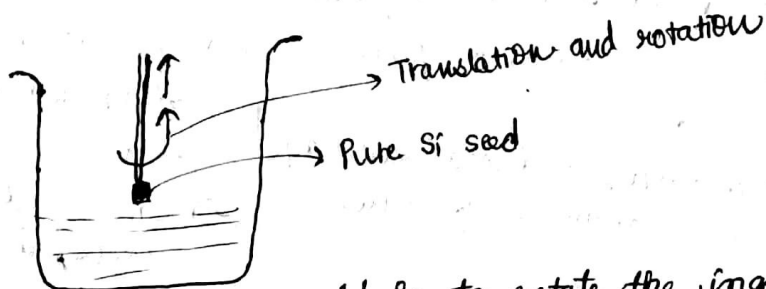
Q1

To make the Czochralski's bulk crystal growth process a continuous process, we could use the following method which is analogous to continuous ingot casting used in manufacturing science:

**Step 1**: In the original Czochralski's process, the powdered silicon was put in a quartz crucible and was melted. To make this a continuous process, we have to use some mechanism that constantly supplies crushed silicon in the crucible. We can use a process similar to one used to supply pulverised coal in power plants, that is through flat-belt conveyor system.

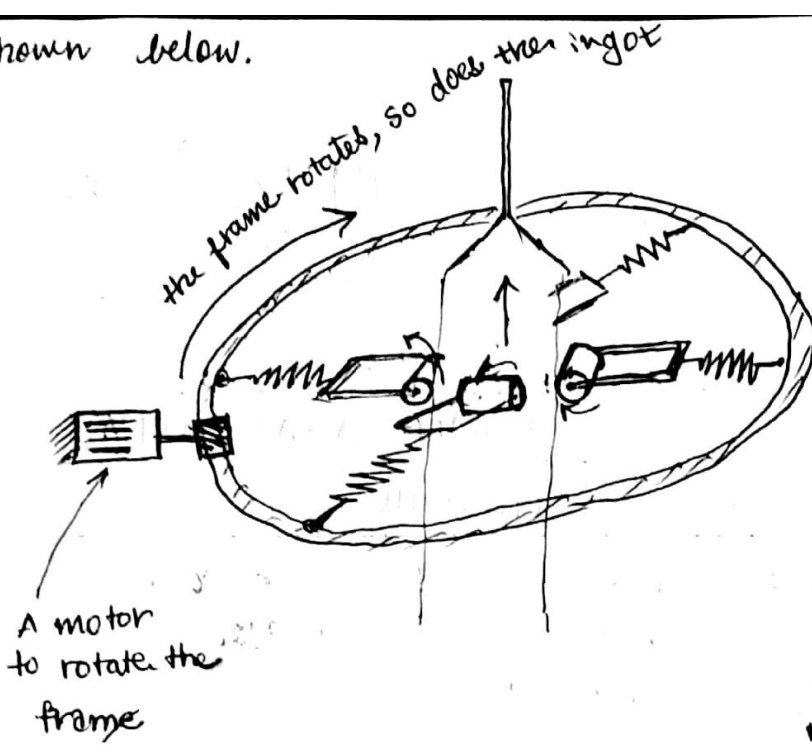


**Step 2**: To initiate the silicon ingot formation process, we would use the same method as the original Czochralski's process of initiating the ingot formation by introducing a pure Si crystal seed. We would dip that seed into that melt and start pulling it up with rotation.



**Step 3**: Perhaps the most difficult step would be to rotate the ingot and pull it up continuously. The translation can be easily done, but the rotation causes a challenge. A proposed mechanism is

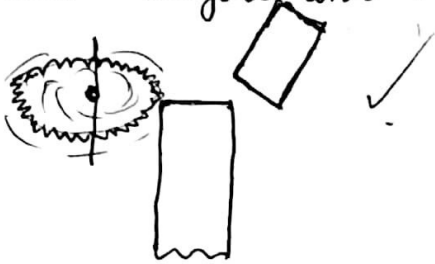
shown below.



A roller wheel that can rotate unidirectionally when in contact with the ingot to pull it up.

A spring force to grip on the ingot with the right amount of force

**Step 4** A precise laser cutter or mechanical cutter to chop off the continuous ingots into required cylinders at the top.



**Step 5** Once we combine them all, we can get our continuous Czochralski bulk crystal growth process (Voila!)

### Advantages

- ⊕ Pretty obvious, increased manufacturing yields.
- ⊕ We would not be requiring the pure Si seed crystal every time.
- ⊕ More automation, reduced average fixed costs, economies of scale.

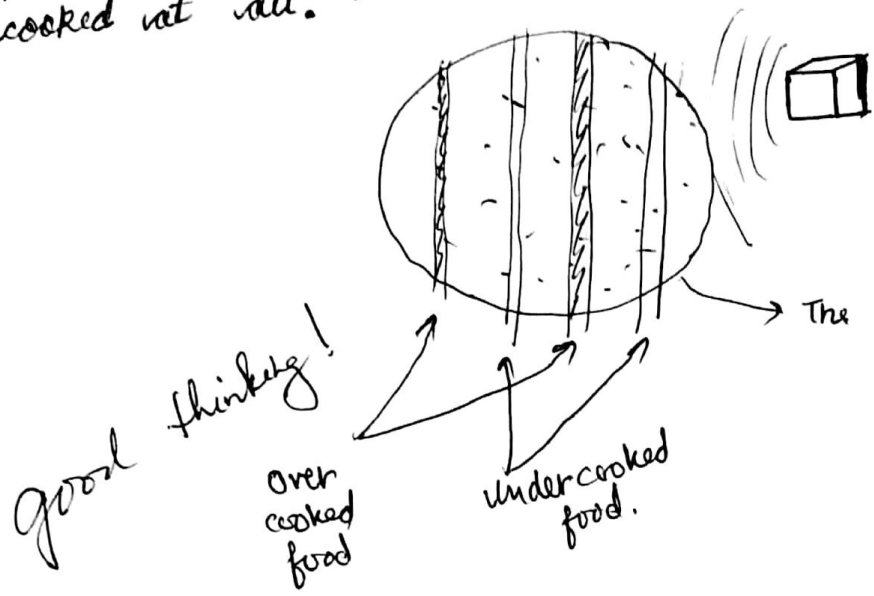
### Disadvantages

- ⊖ More mechanical, hence more reliability and maintenance issues.
- ⊖ To obtain a uniform ingot diameter, more sensors and electronics would be involved.
- ⊖ Increased average variable costs, increased investment.

Q2

Since the soldering process takes place in the solder reflow oven, we would use the concept of a similar and much common other oven, the microwave oven (that cooks our food)

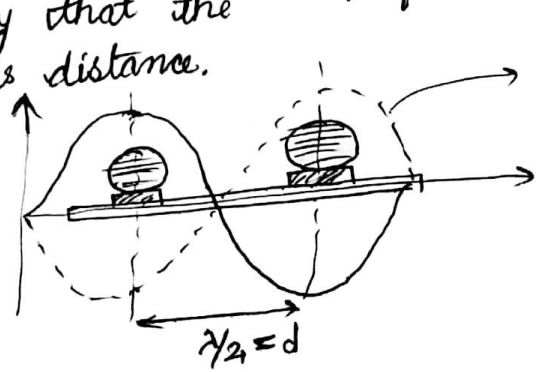
If in a microwave oven, we stop the rotation of the container in which food is kept and operate the oven, we would find interesting patterns of spots where the food is overcooked and where it isn't cooked at all.



The pie which we wanna microwave!  
Use Wien's Law  
 $\lambda T = \text{const.}$

This happens because of the formation of standing waves in a microwave. So obviously, where there is a <sup>anti-</sup>node, the energy (amplitude) is maximum and the food is cooked way better and where there is a node, the energy is minimum (almost zero) and food isn't cooked very well. Measuring the distance between two adjacent cooked spots, we can tell the <sup>half-</sup>wavelength of microwave to be around 6 cm, which matches pretty well with its 2.4 GHz frequency.

Building on the same principle, to determine the frequency of the IR waves used, we would measure the distance between the adjacent solder bumps and will try to adjust the frequency in such a way that the matches this distance.  $\lambda/2 = d$



standing waves  
 $\therefore c = \lambda f$   
 where  $\lambda = 2d$   
 $\Rightarrow \boxed{f = \frac{c}{2d}}$

$c \rightarrow$  speed of light  
 $f \rightarrow$  frequency of IR source  
 $\lambda \rightarrow$  wavelength of standing wave  
 mech14.weebly.com

A few protips:

- ① The multiples of this frequency which cause an anti-node at solder bumps can also work.
- ② It is also necessary to know the location of such anti-nodes in the oven.